



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8591

SERIAL NUMBER 10/774,701	FILING OR 371(c) DATE 02/10/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 049128-5144
-----------------------------	--	--------------	------------------------	---------------------------------------

APPLICANTS

Byung Chul Ahn, Kyounggi-do, KOREA, REPUBLIC OF;
Byoung Ho Lim, Kyoungsangbuk-do, KOREA, REPUBLIC OF;
Byeong Dae Choi, Daegu, KOREA, REPUBLIC OF;

** CONTINUING DATA *****

none (A/C)

** FOREIGN APPLICATIONS *****

A/C REPUBLIC OF KOREA 2003-8159 02/10/2003
REPUBLIC OF KOREA 2003-19782 03/29/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

04/10/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 50	TOTAL CLAIMS 87	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>delemb</i> Examiner's Signature _____ Initials _____				

ADDRESS

09629

TITLE

Method of patterning transparent conductive film, thin film transistor substrate using the same and fabricating method thereof

FILING FEE RECEIVED 2364	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit